

OUTLINE

› Gas Chromatography primer

› Applications

› APIX, a startup company experience

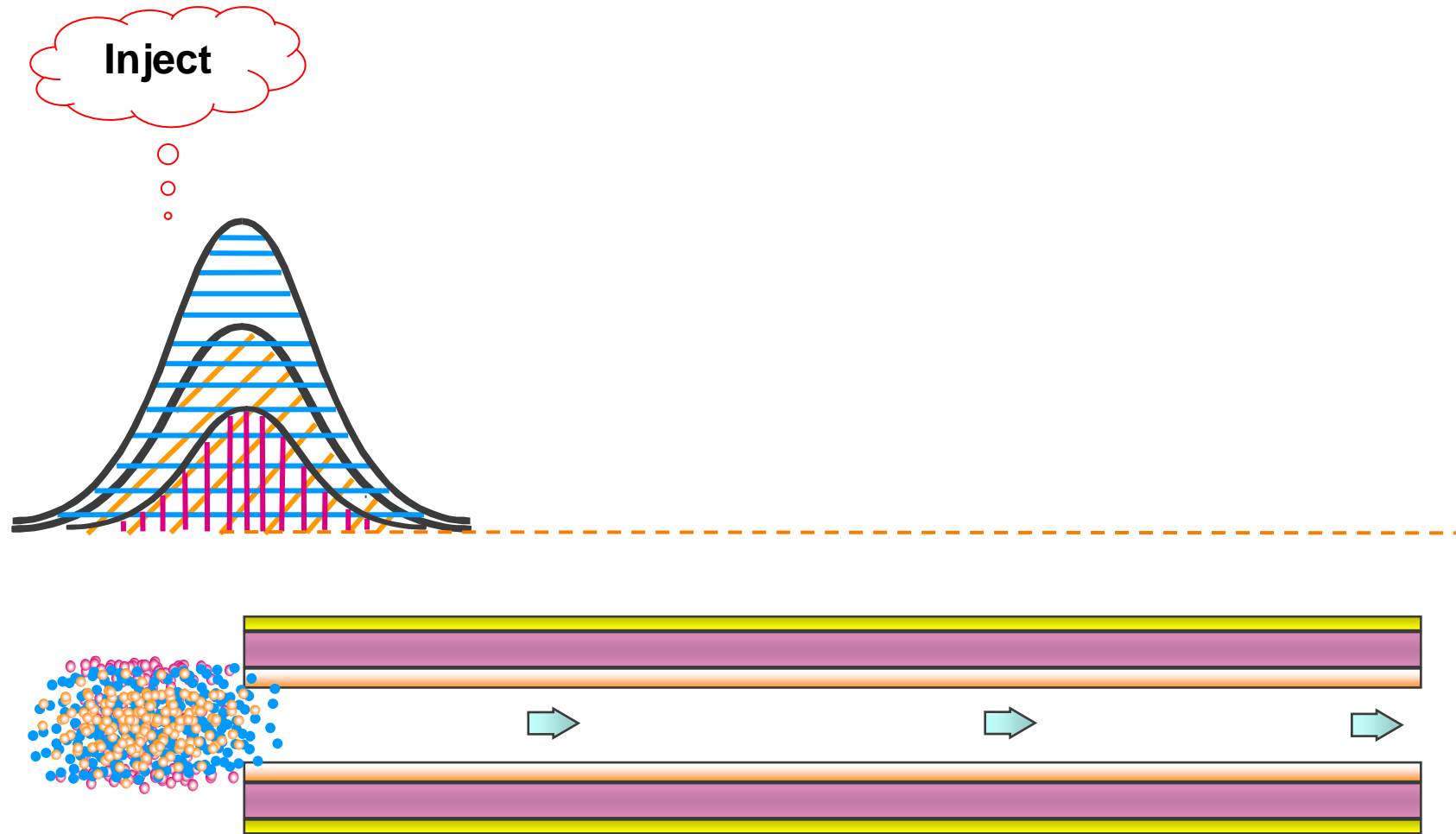
pierre.puget@m4x.org



PRINCIPLES

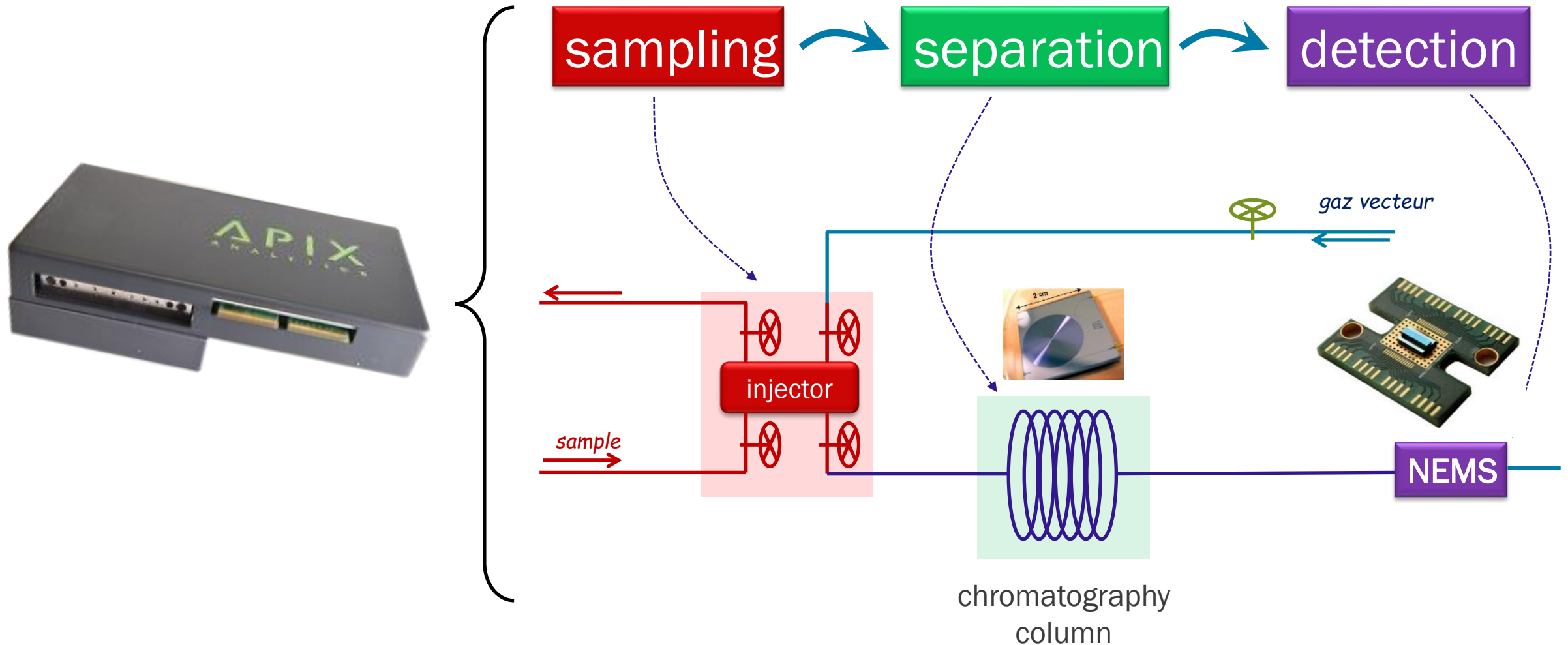


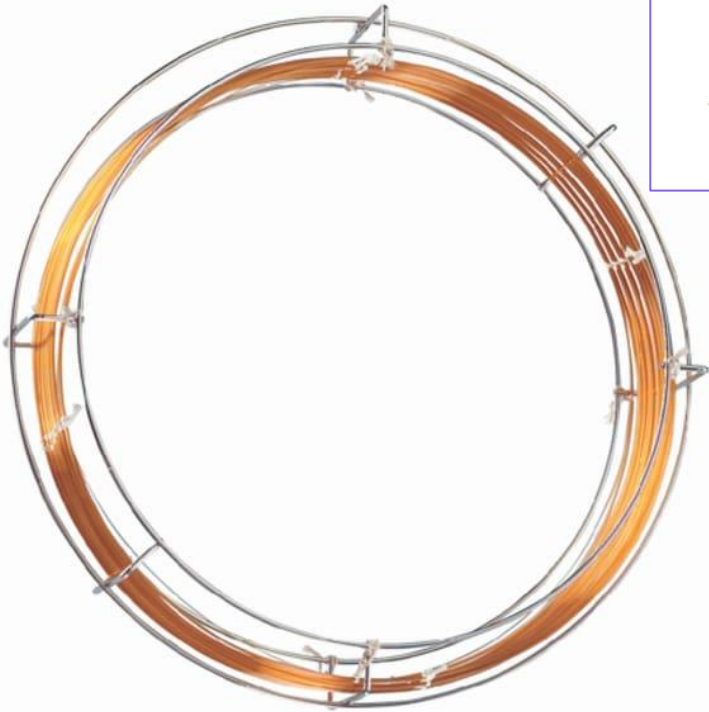
PRINCIPLE OF GAS CHROMATOGRAPHY





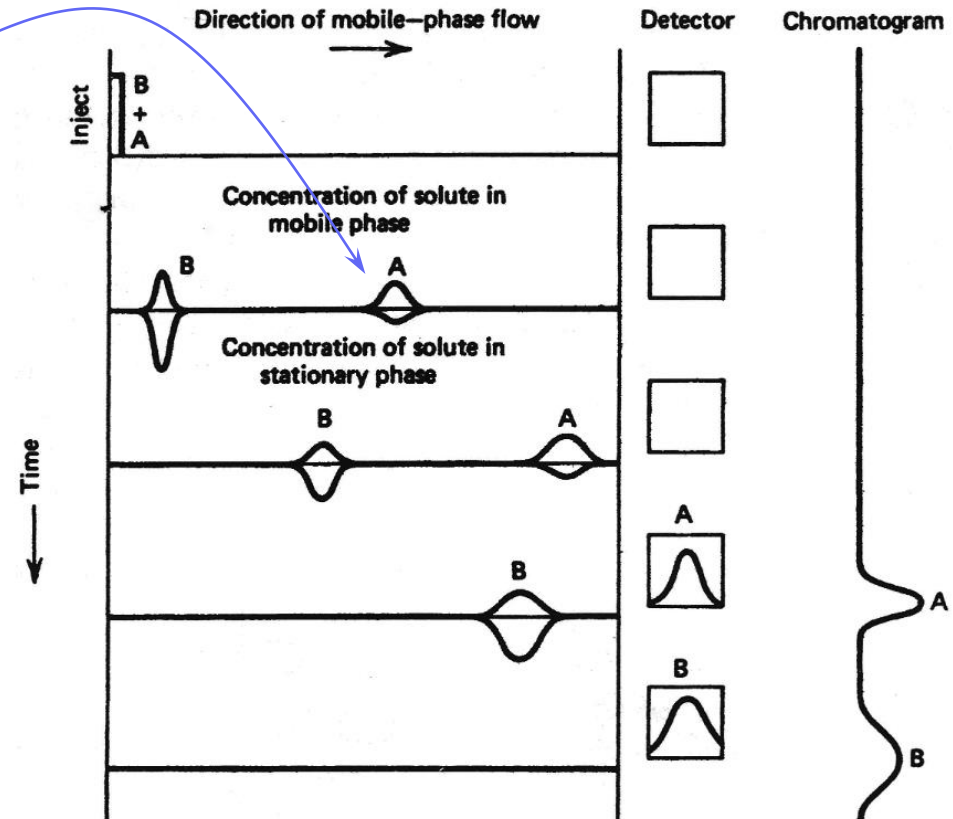
OUR PRODUCTS: PLUG & PLAY GC MODULE





length ~ a few to a few 10s meter range
diameter ~ 100 μm

$$K_c = \frac{[A]_s}{[A]_M}$$



to remember:

- control the flow (pressure) of carrier gas
- control the temperature of the column

Schematic representation of the chromatographic process. Adapted from Harold M. McNair, James M. Miller, *Basic Gas Chromatography*, John Wiley & Sons, New York, 1998. Reproduced courtesy of John Wiley & Sons, Inc.
source: LibreTexts Chemistry, ch 3.1: Principles of Gas Chromatography



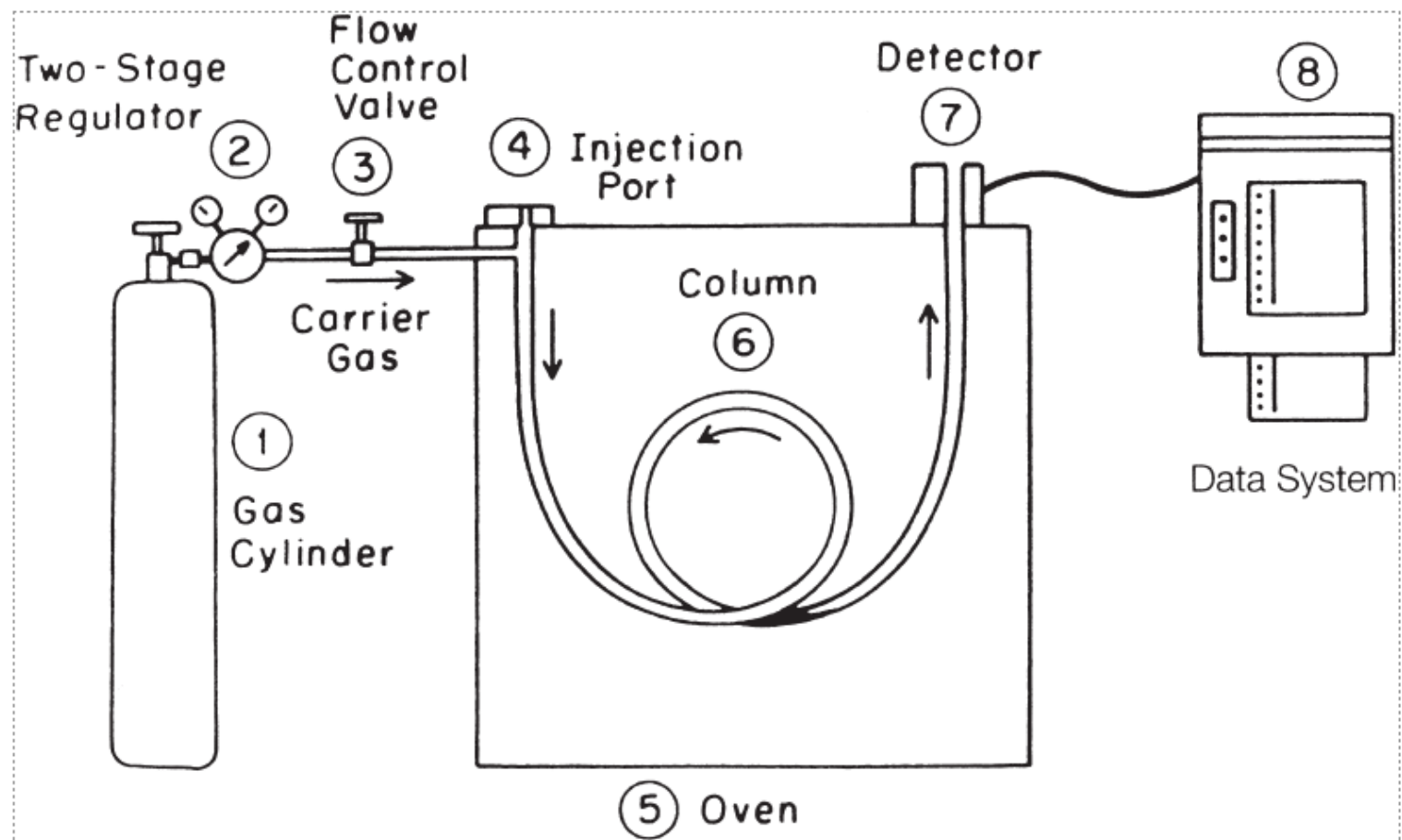
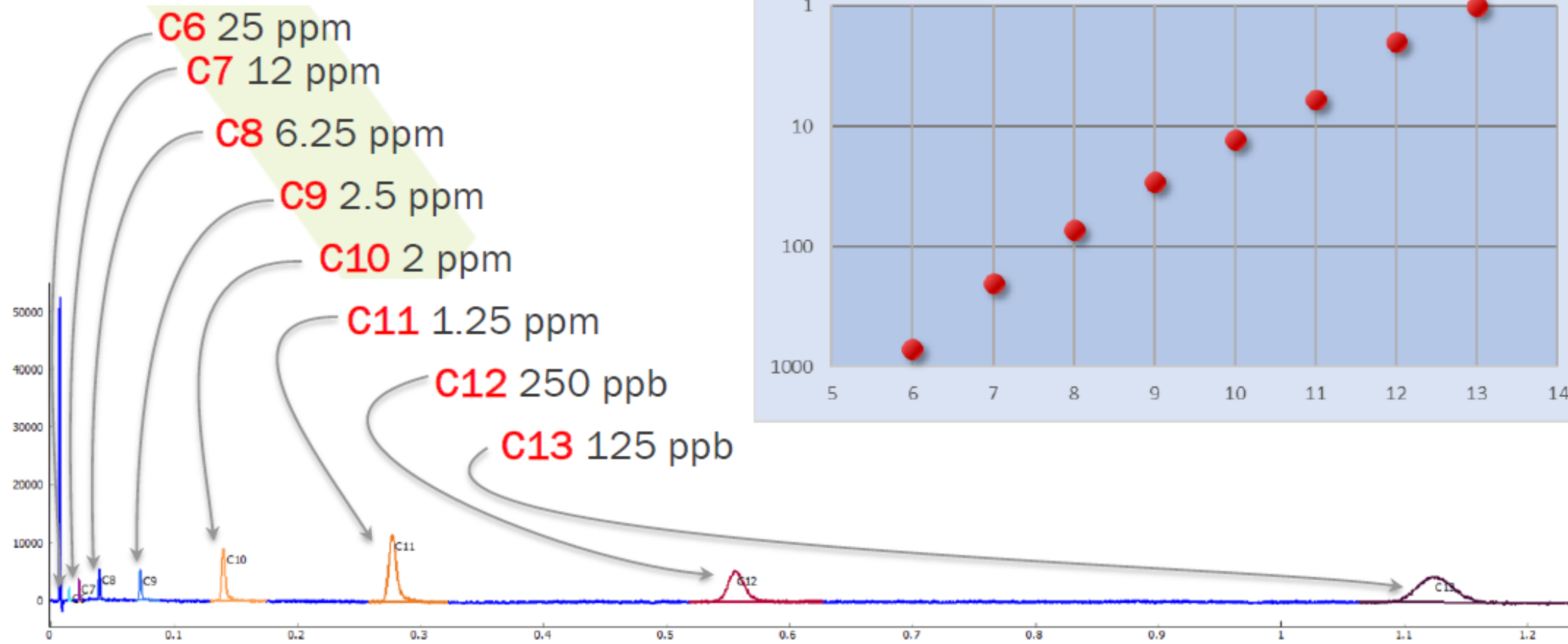


Fig. 1.8. Schematic of a typical gas chromatograph.





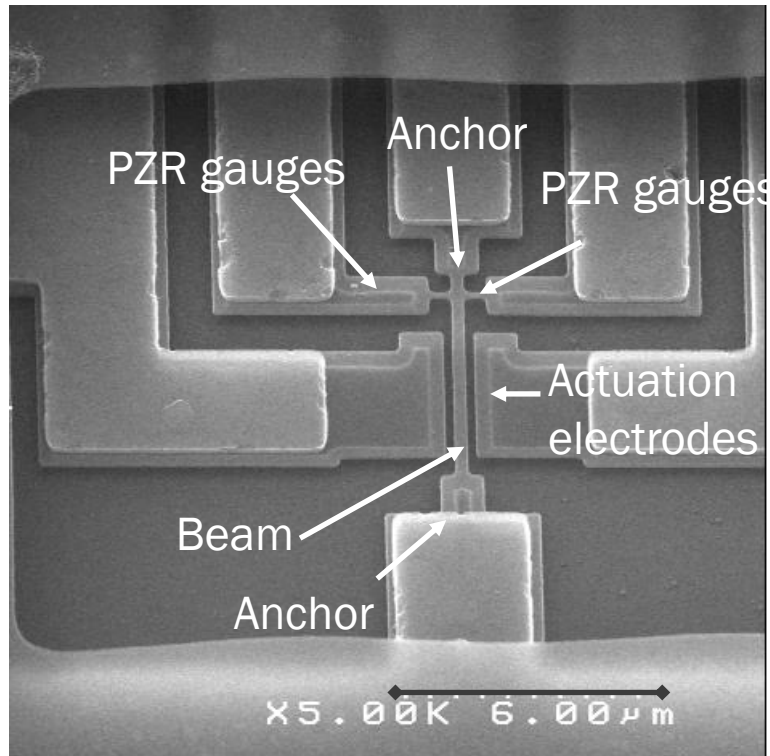
ANALYSIS OF ALKANES C6 TO C13 WITH NGD



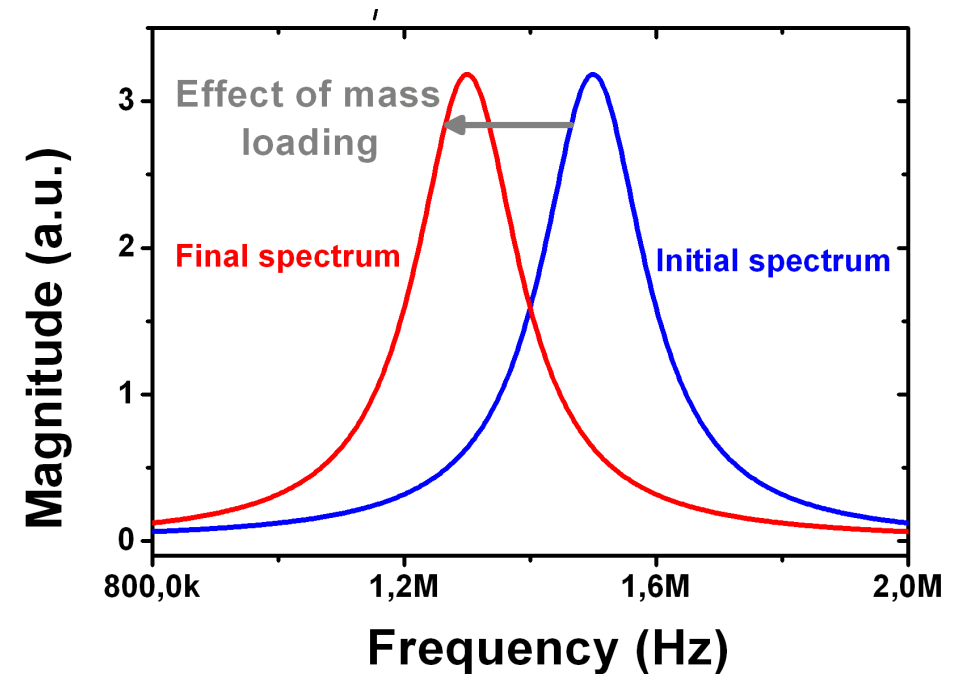


Our NEMS gravimetric detector (a.k.a. NGD / Nano Gravimetric Detector)

1. resonating structure covered with a sensitive layer



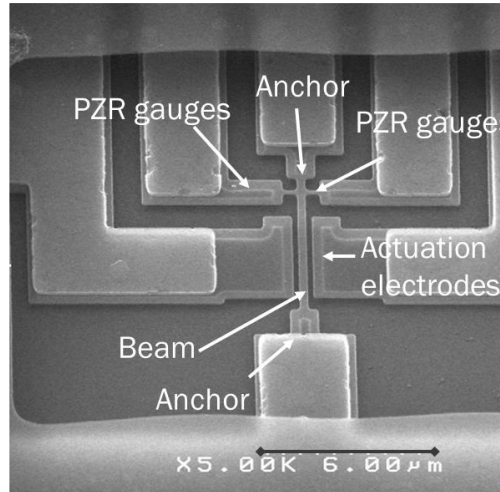
2. adsorption of compounds causes resonance frequency shift



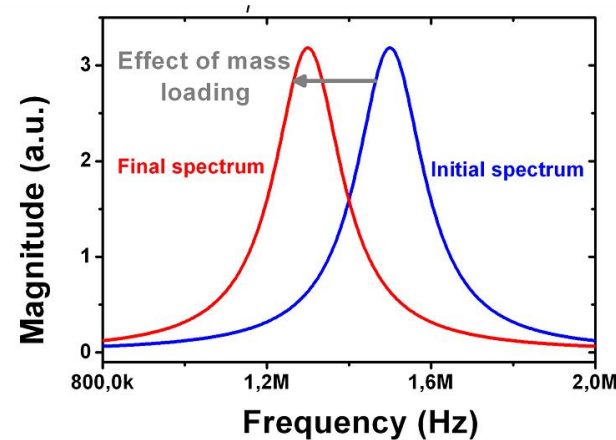


Our NEMS gravimetric detector (a.k.a. NGD / Nano Gravimetric Detector)

1. resonating structure covered with a sensitive layer



2. adsorption of compounds causes resonance frequency shift

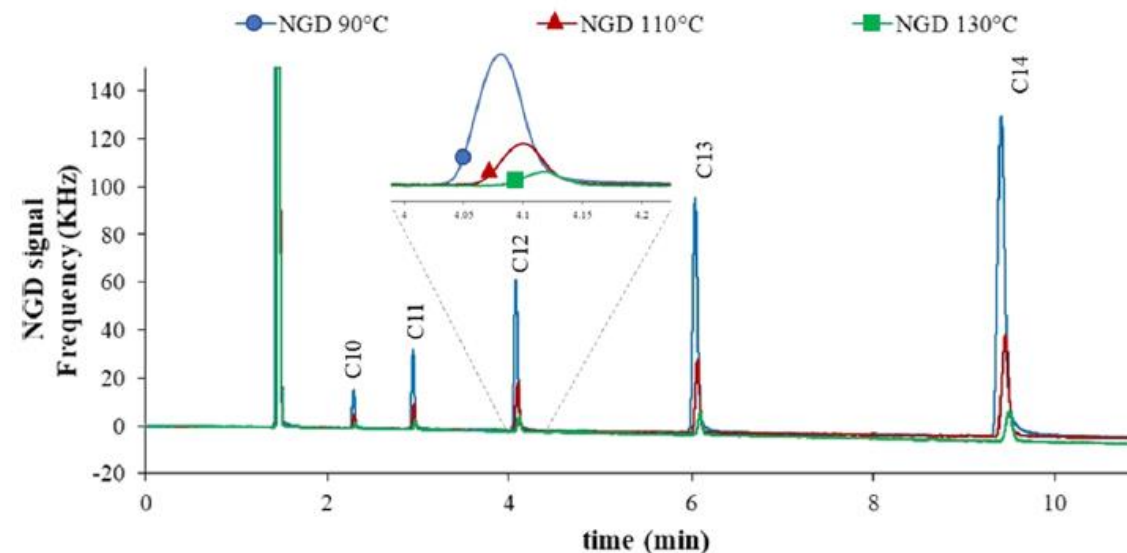
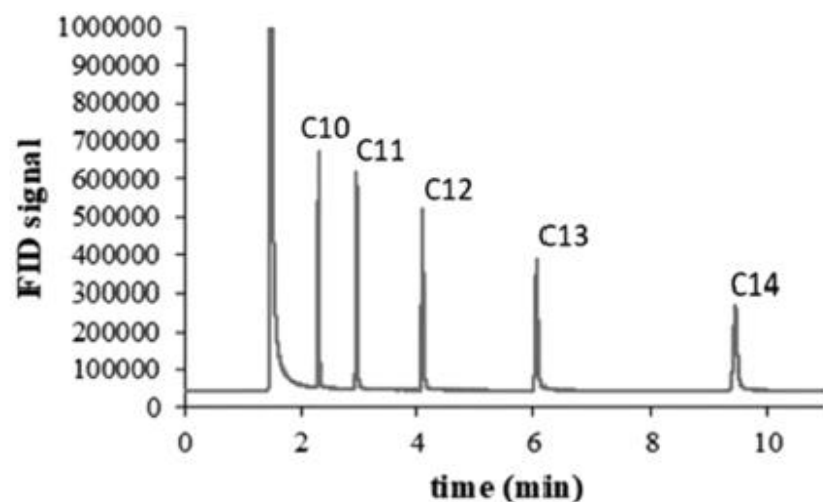
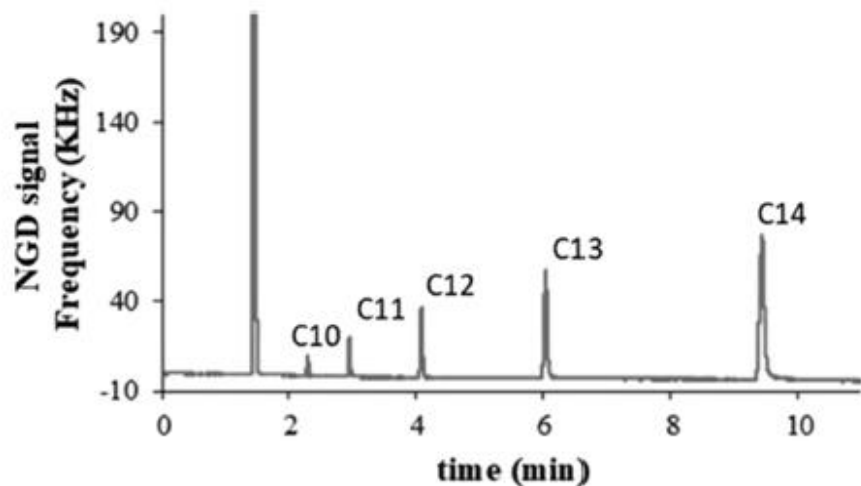


$$K_c = \frac{[A]_s}{[A]_M}$$

to remember:

- freq. shift proportional to vapor concentration
- but sensitivity strongly depends on size of molecule (linear) and temperature (exponential)

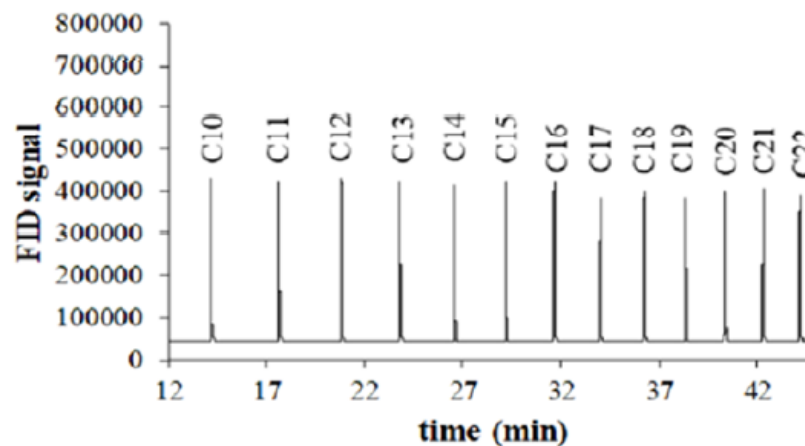
EFFECT OF TEMPERATURE: COLUMN AND NGD ISOTHERMAL



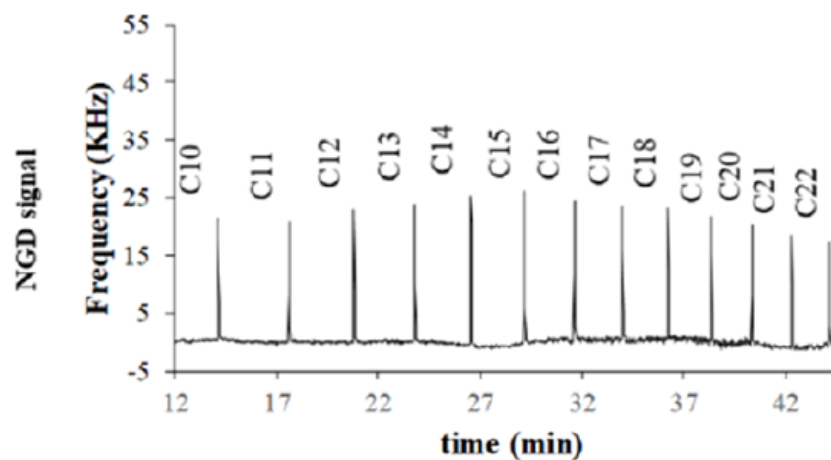
ref: L. Alonso Sobrado *et al.*, « Characterization of Nano-Gravimetric-Detector Response and Application to Petroleum Fluids up to C₃₄ », *Anal. Chem.*, vol. 92, n° 24, p. 15845-15853, déc. 2020, doi: [10.1021/acs.analchem.0c03157](https://doi.org/10.1021/acs.analchem.0c03157).



EFFECT OF TEMPERATURE: COLUMN AND NGD TEMPERATURE PROGRAMMING / RAMP



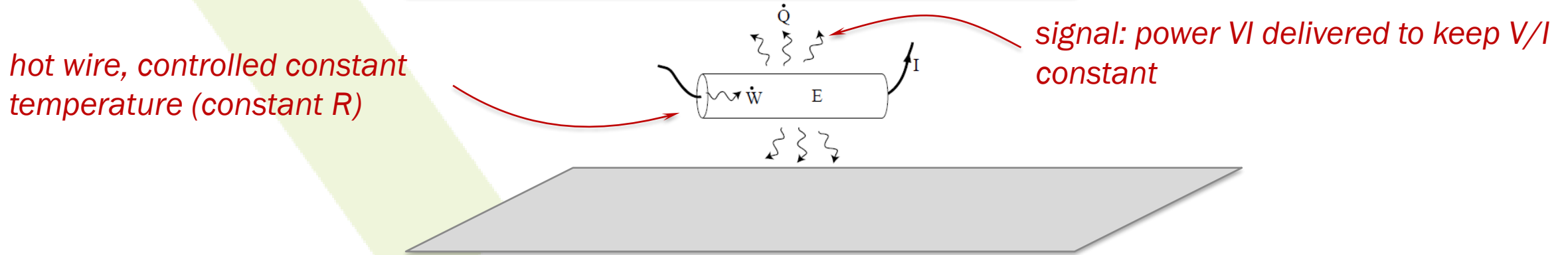
Observed NGD chromatogram



ref: L. Alonso Sobrado *et al.*, « Characterization of Nano-Gravimetric-Detector Response and Application to Petroleum Fluids up to C₃₄ », *Anal. Chem.*, vol. 92, n° 24, p. 15845-15853, déc. 2020, doi: [10.1021/acs.analchem.0c03157](https://doi.org/10.1021/acs.analchem.0c03157).



THERMO CONDUCTIVITY DETECTOR



› puissance échangée avec l'écoulement de gaz:

- conduction / diffusion dans le volume du gaz
- convection

les deux termes dépendent des caractéristiques du gaz ambiant (gaz vecteur ou analyte)

› sources de bruit:

- perturbations dans l'écoulement (variation de la pression d'entrée et/ou de sortie de l'écoulement)
- perturbations thermiques
 - température du composant 'bulk' (contrôle commande de l'instrument)
 - température du filament (électronique de lecture du détecteur)





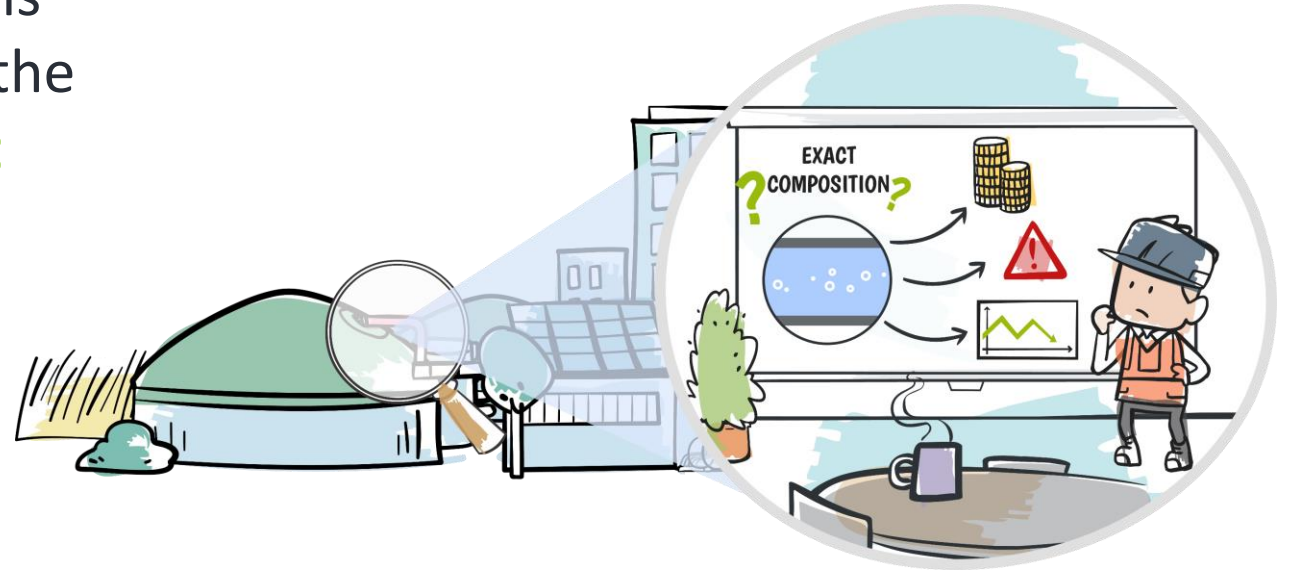
APPLICATIONS / MARKETS



WHY DO WE NEED TO MEASURE GAS COMPOSITIONS?

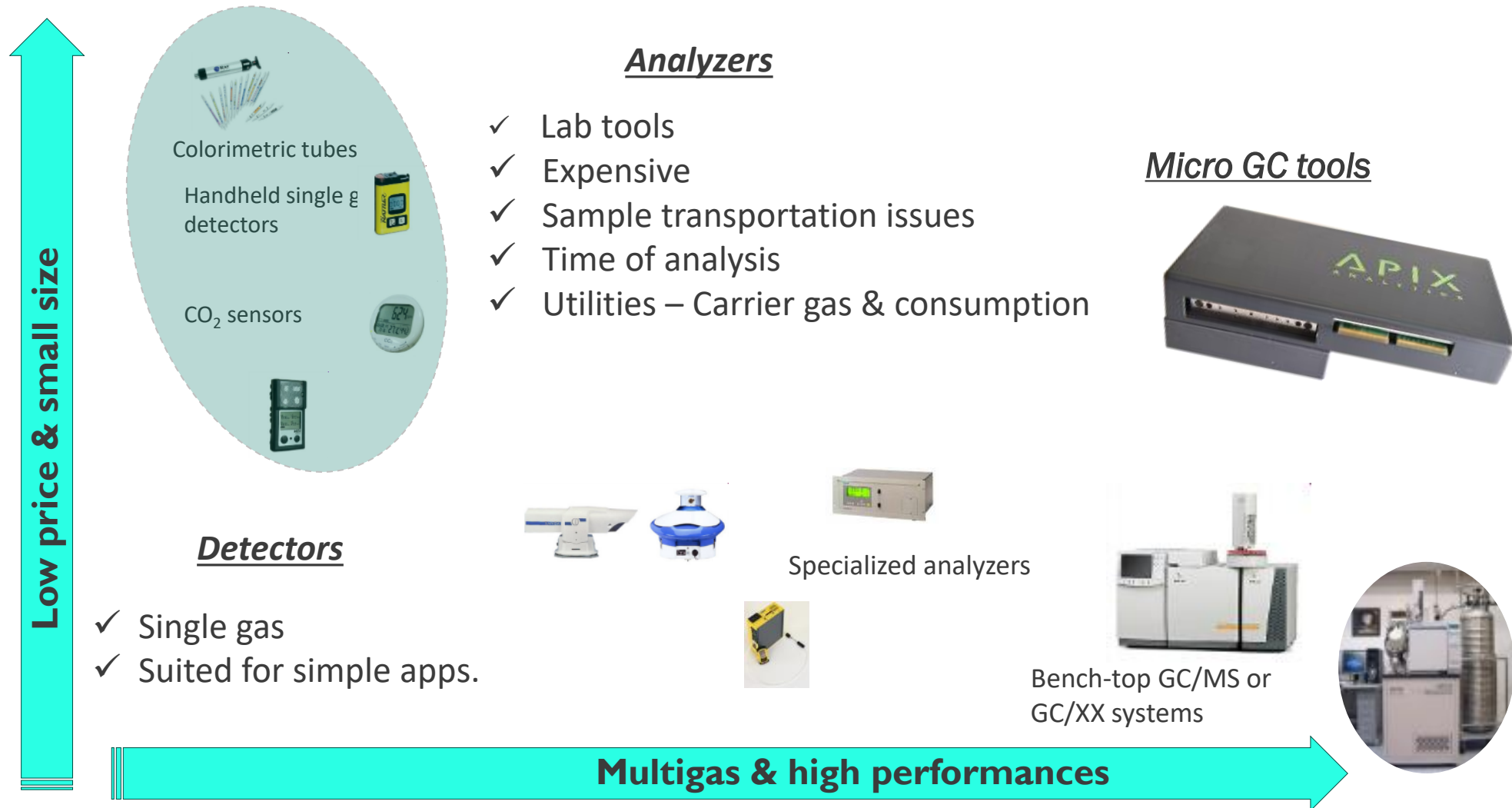
The **exact composition** of the gas is critical for operators evolving in the field of **energy and environment**

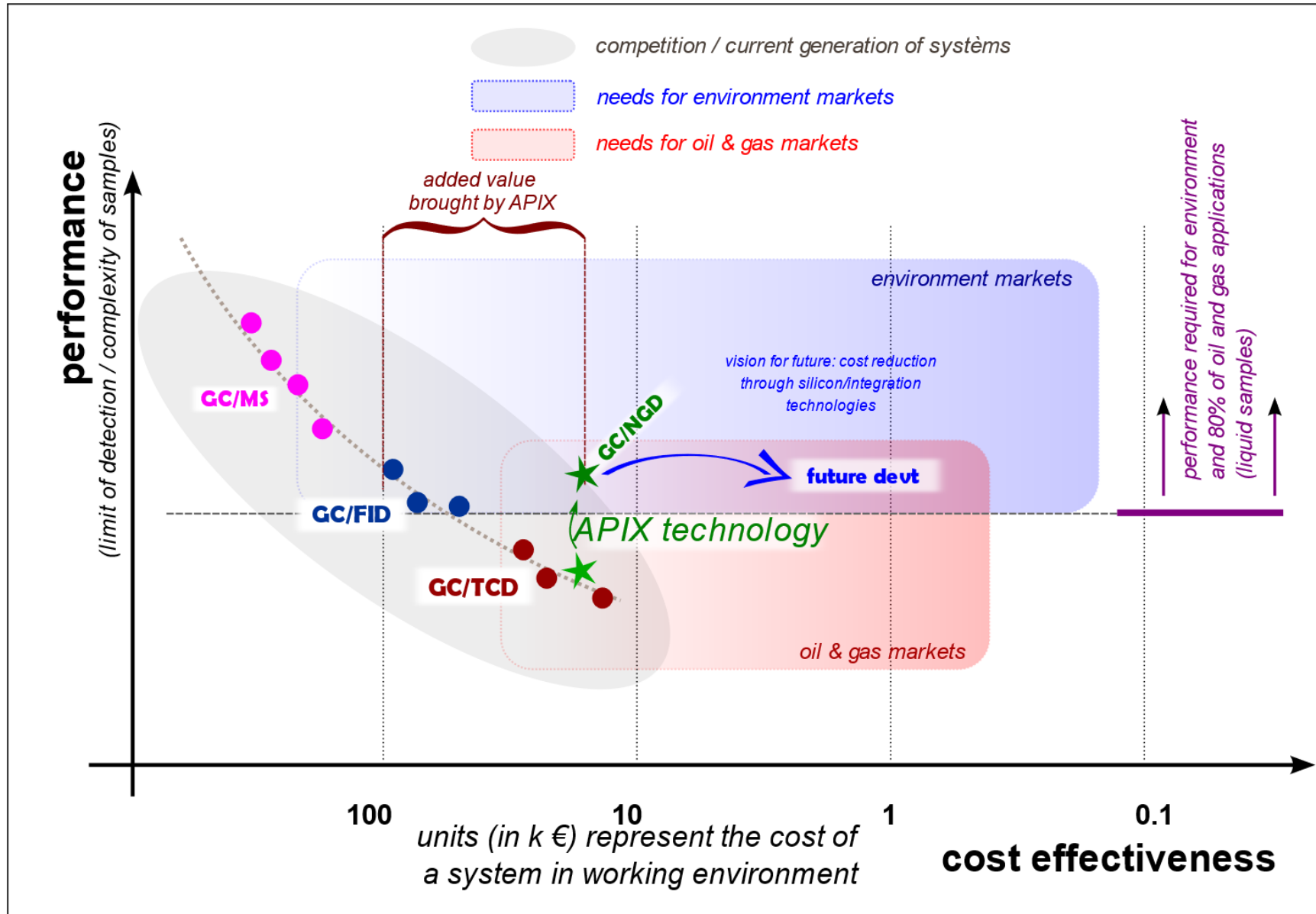
- **Control** of productivity
- Improved **responsiveness**
- **Lower** costs
- **Reduce emission**





WHAT TECHNOLOGIES ARE AVAILABLE TO MEASURE GAS?







NUMEROUS KEY APPLICATIONS

HYDROGENE

Production & process control
Purity
Quality

REFINERY GASES

Fuel gas composition
Flare gas monitoring
CO₂ emission

NATURAL GAS (ASTM D1945)

Quality
Energy content
Custody transfer
Odorization control

INDUSTRIAL AND SPECIALTY GASES

Purity
Quality

INDUSTRIAL EMISSIONS AND VOCS

Outdoor air quality
Indoor air quality
VOCS
BTEX

BIOMETHANE

Methanisation process
Energy content
Injection to the distribution grid
Odorization control
Control of impurities (sulfur compounds)





OUR BENEFITS



All-in-One analyzer for process

Capability to analyze all parameters of interest in a single system (4 modules)

>50% CAPEX Reduction



Reduced OPEX

Low carrier gas consumption

Carrier gas can be Air for the NEMS

No need of services from a GC expert



Small footprint

Measurement in situ, right at the sampling point with limited infrastructure and space requirements



Reduced Infrastructure costs

Measurement in situ, right at the sampling point with limited infrastructure and space requirements



Faster Measurements

Shorter measurement cycle times for faster decisions thanks to miniaturization

Cycle time <1 min vs 10+ min



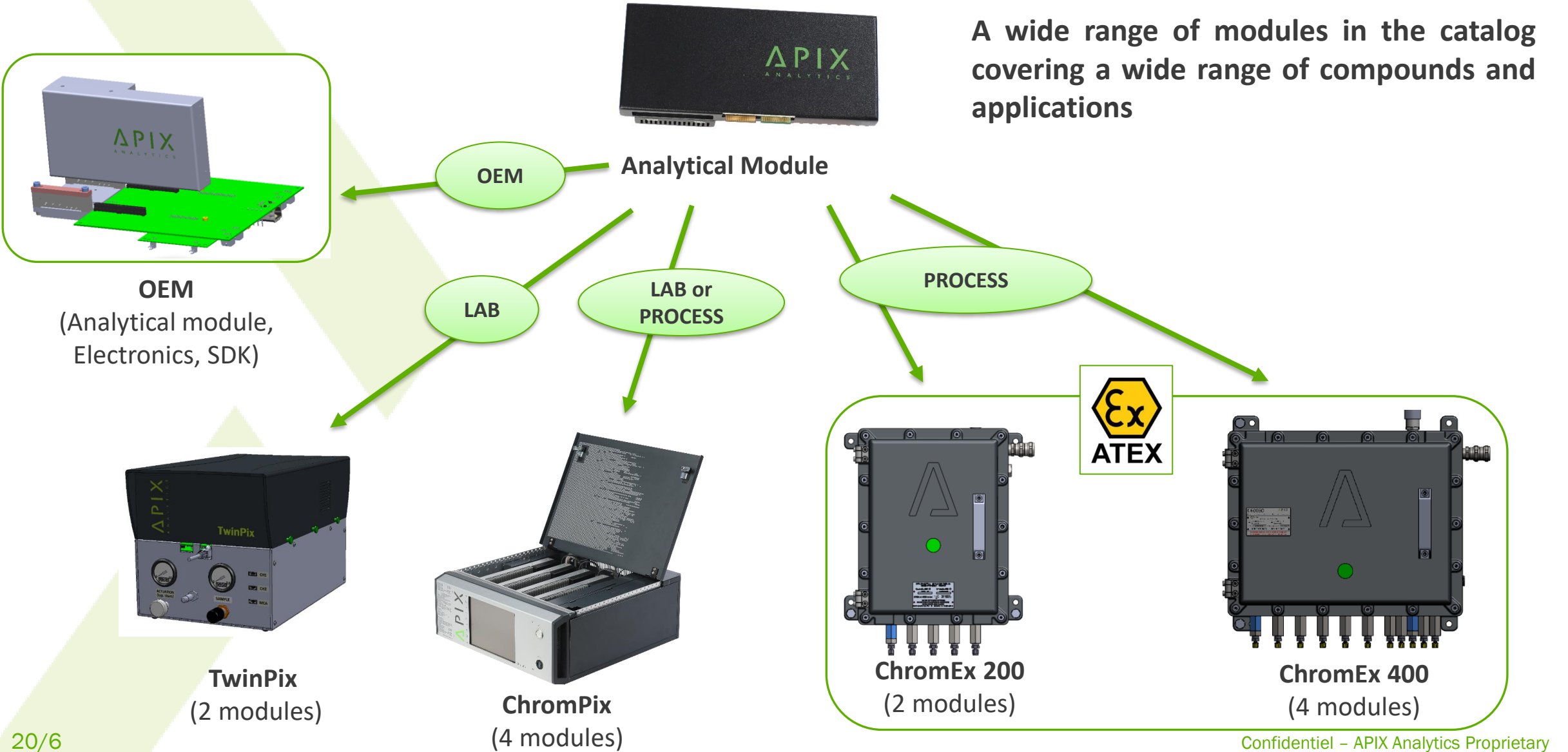
Wide range of detection

Intrinsically safe detector (No flame, no H₂)
Wider detection spectrum with the combination of micro TCD and NEMS



PRODUCTS CURRENT GENERATION

MODULAR ARCHITECTURE



TECHNOLOGICAL ROAD-MAP

MODULES

2016



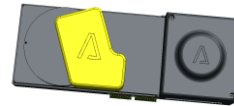
V1 Modules
First generation of analytical modules

2017



MI100G
Second generation of modules (isothermal)

2018



MI100G-R2
Optimized module with regeneration function

2019



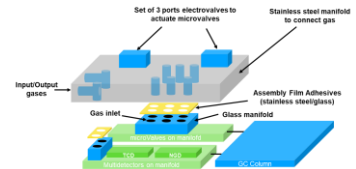
ML
Module for liquid analysis

2020



MRT100G
New module with temperature ramp function

2021



GREENPIX
Integrated module on manifold

2022

2023

2024

SYSTEMS



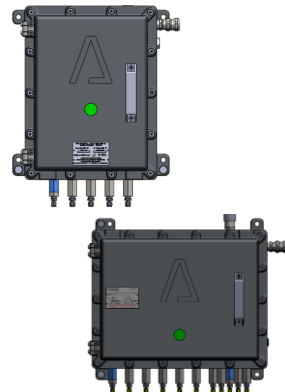
ChromPix® V1
Product launch



MaxONE® V1
Product launch



ChromPix® V2
Product launch



ChromEx® 200/400
Product launch



NanoPix®
Product launch



AlphaPix®
Product launch

GREENPIX

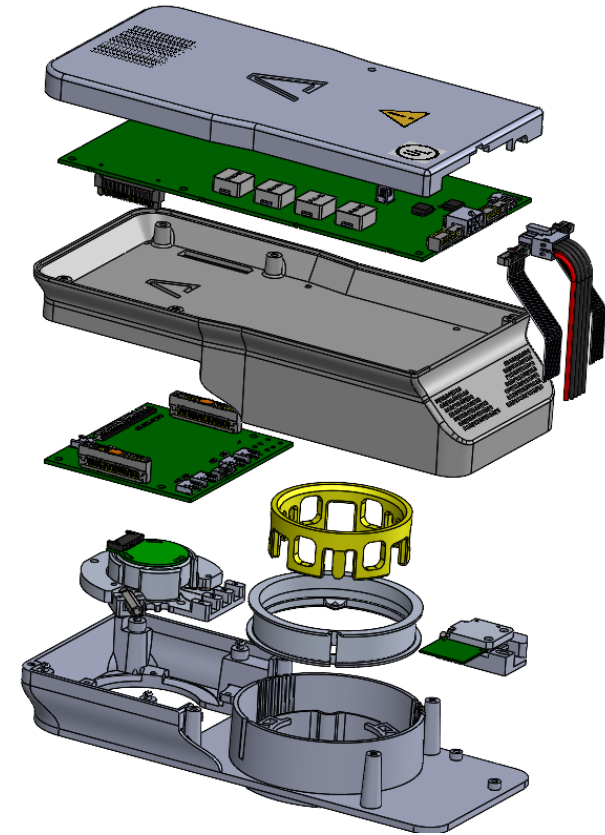
GREENPIX SYSTEM
All-in-one system



GREENPIX: A NEW GENERATION

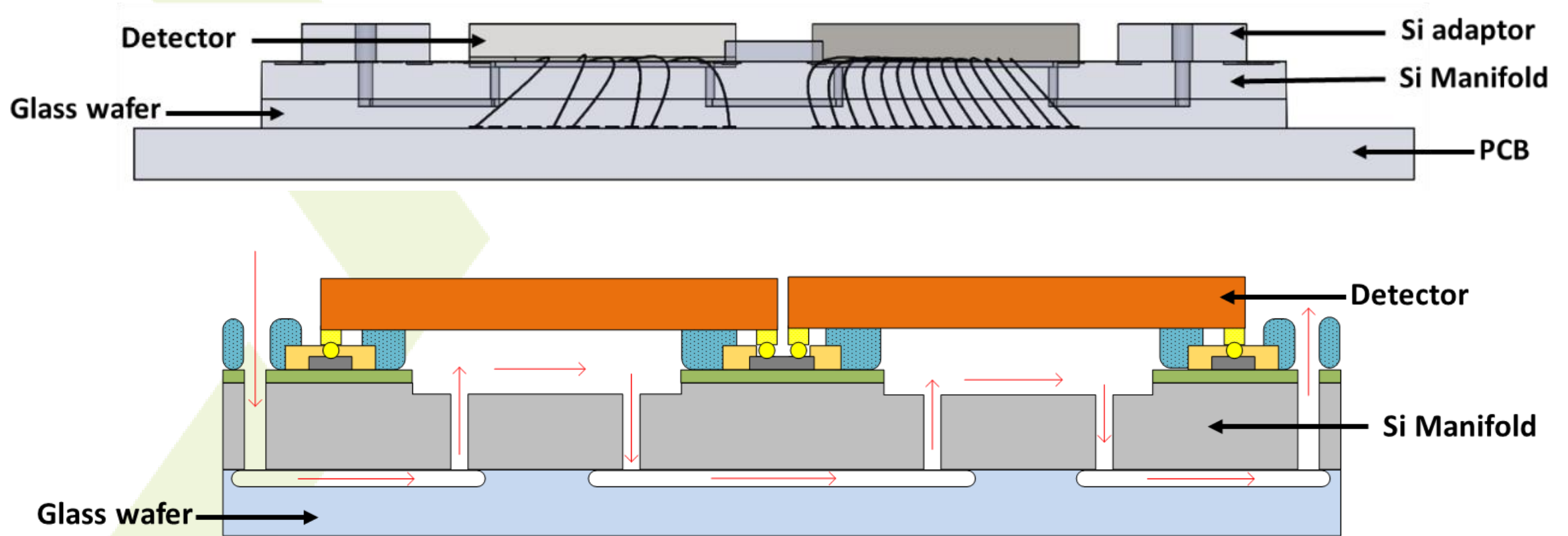


FROM 'SPIDER' MICROFLUIDICS TO 'INTEGRATED' MICROFLUIDICS

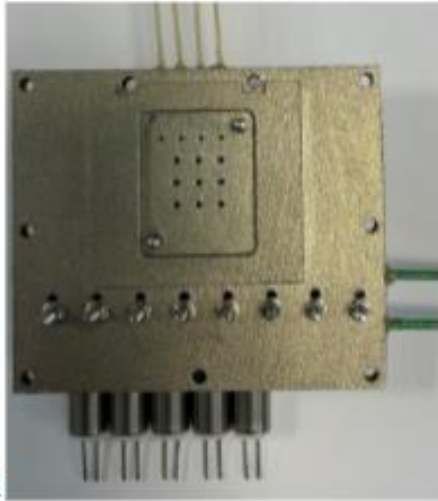




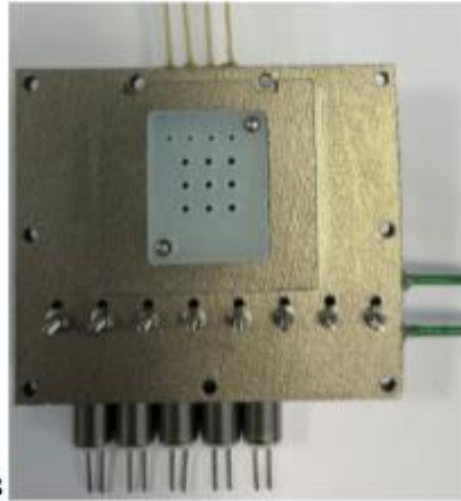
MULTIDETECTOR FABRICATION PROCESS



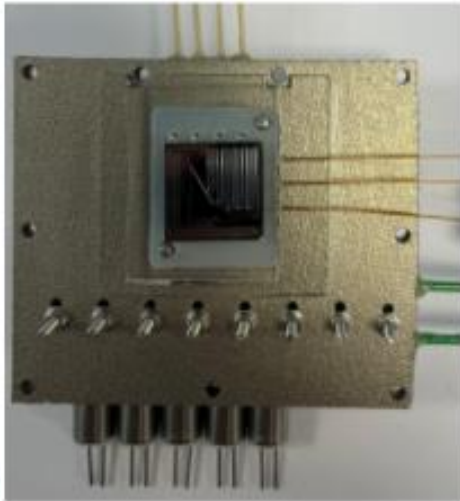
MICRO INJECTOR ASSEMBLY



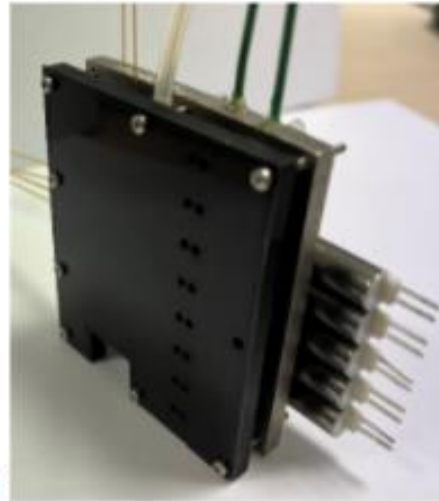
A



B



C

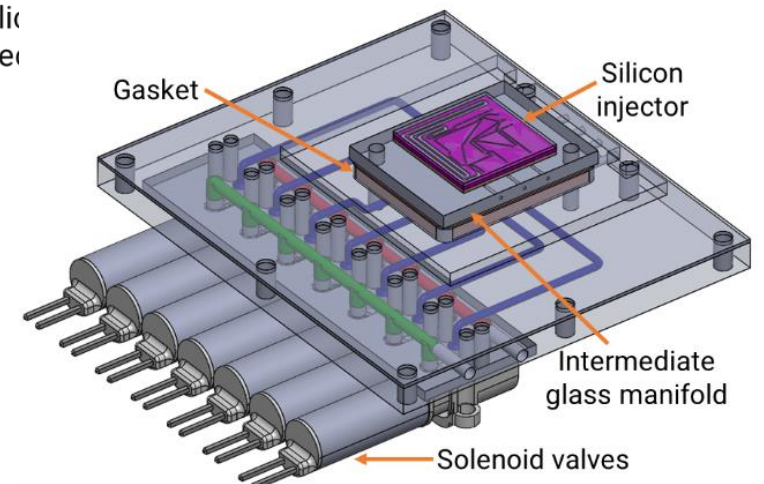
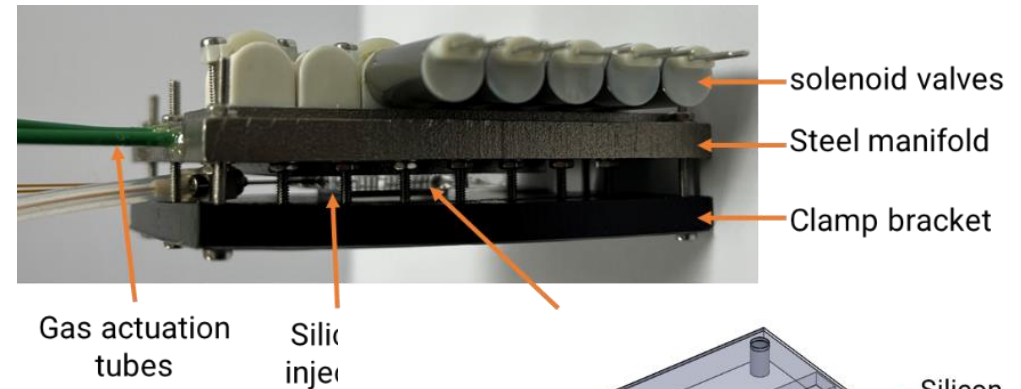


D

Assembly of silicon injector with intermediate glass manifold on the steel manifold using a gasket.

(A) Lower view of the steel manifold. (B) Steel manifold with the gasket placed in the dedicated area.

(C) Silicon injector with intermediate glass manifold placed on the gasket. (D) Clamp bracket in contact with the lower side of the silicon injector and is fixed to the steel manifold.

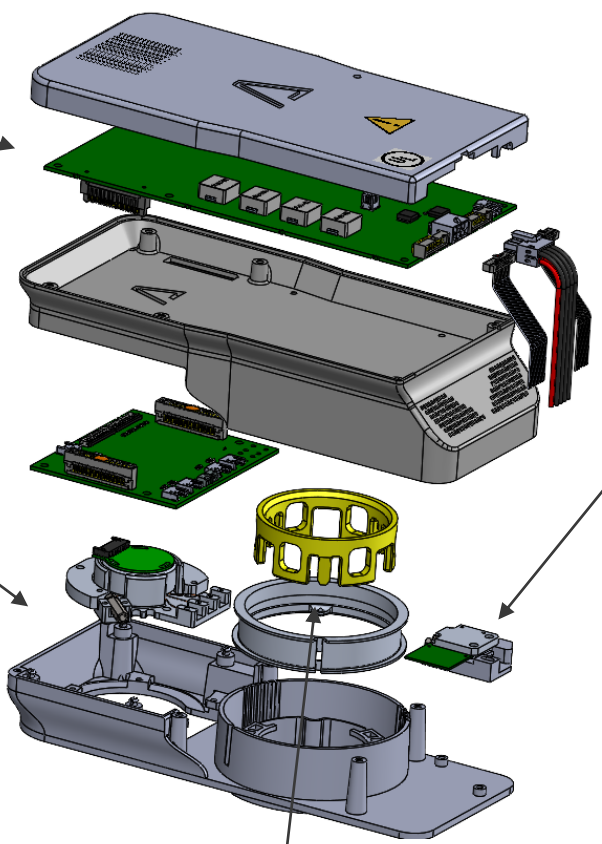
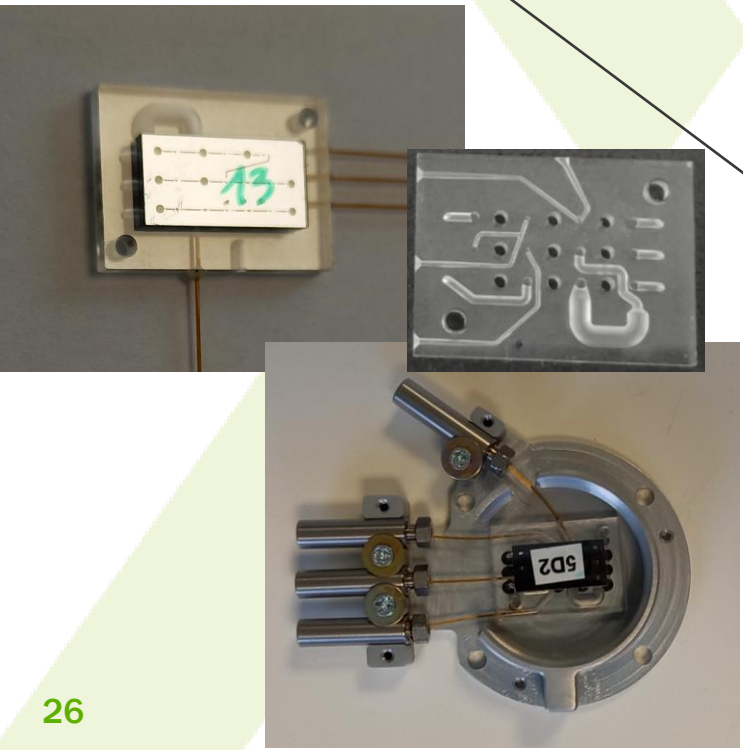


INSIDE THE GREENPIX MODULE

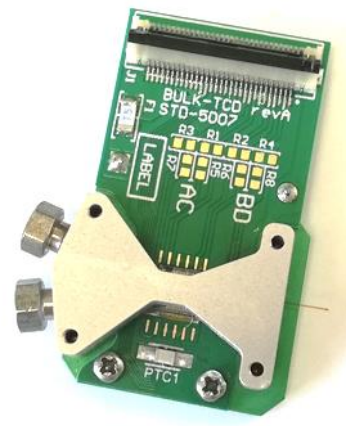
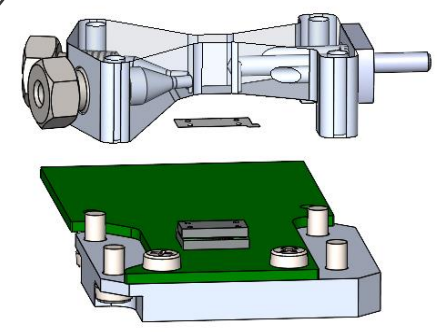
Electronic board

Fully encapsulated silicon injector

Fully encapsulated detector with no capillaries



GC capillary column

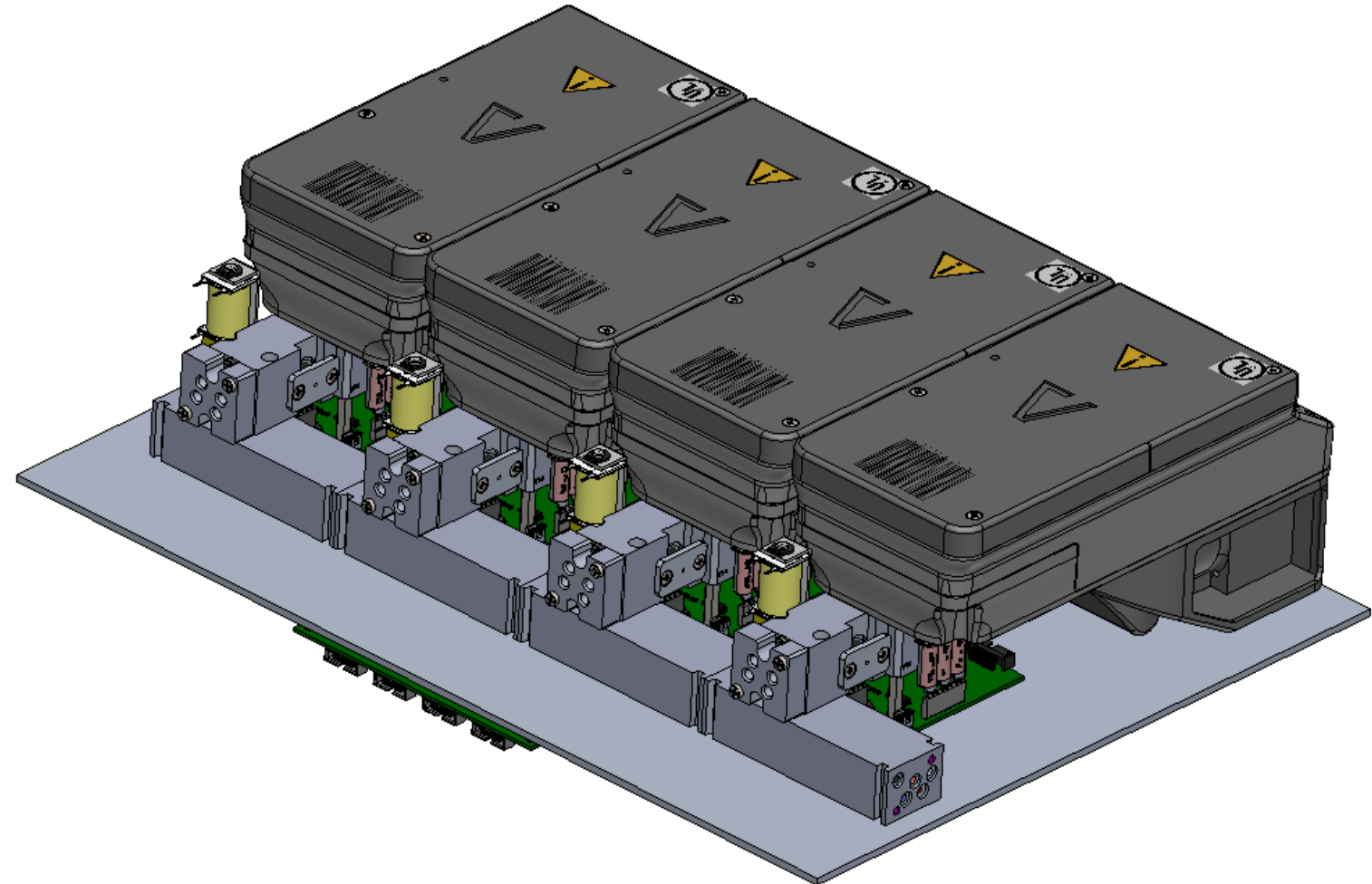
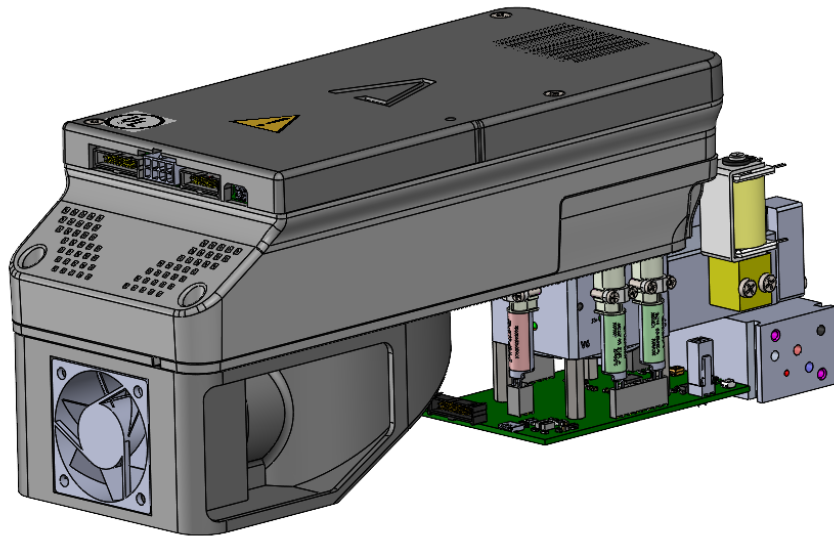


Double detection TCD/NGD chips

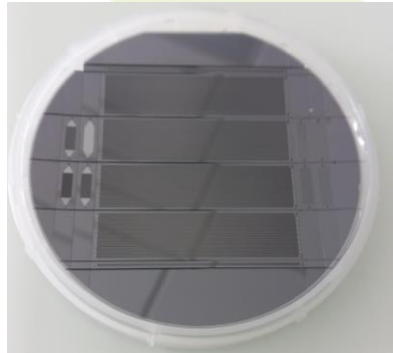




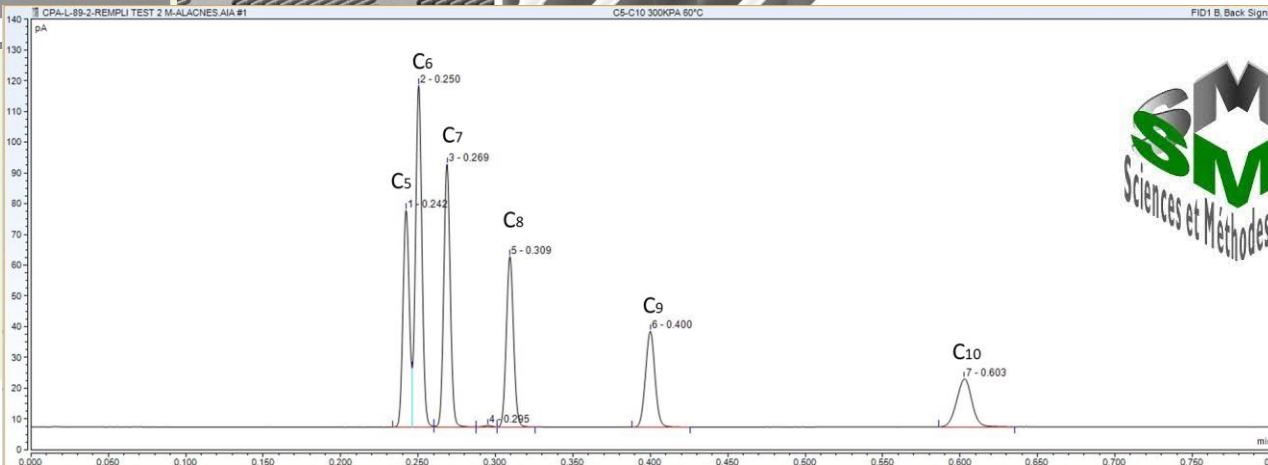
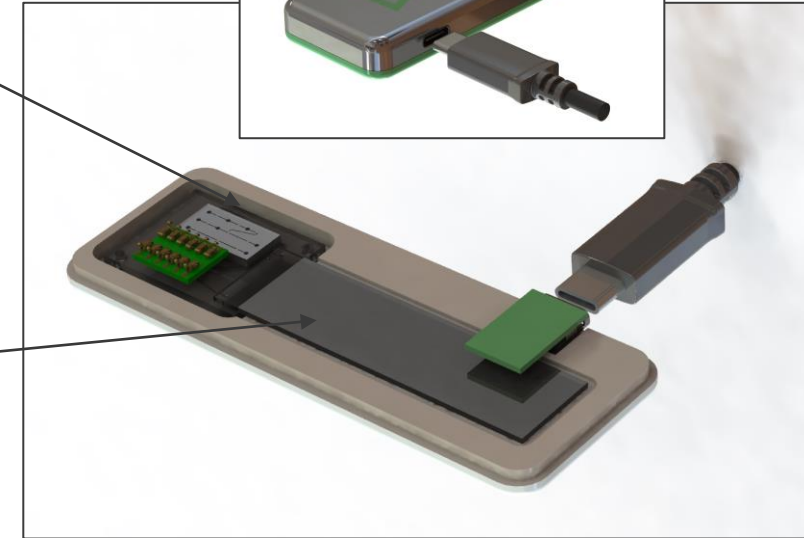
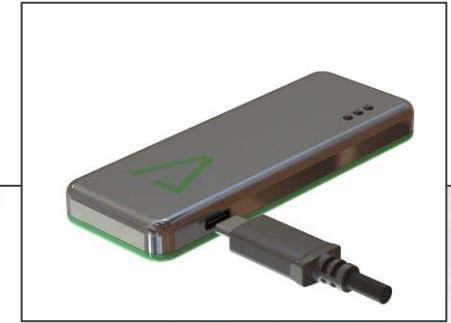
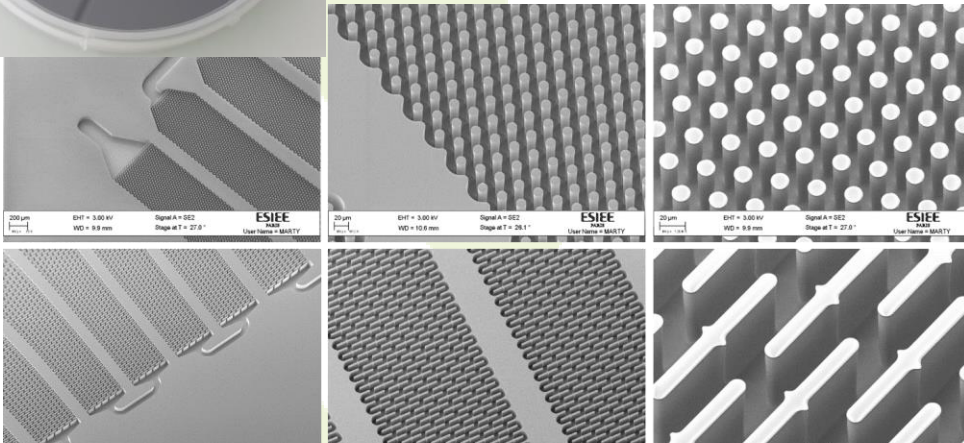
CONNECTION OF MULTIPLE ANALYTICAL MODULE IS MADE EASY IN A VERY COMPACT FORM FACTOR



TOWARD A FULL SILICON GC!



μGC Silicium



Collaboration SMS (et ISA) pour
fonctionnalisation μGC Silicium

Confidentiel – APIX Analytics Proprietary



APIX COMPANY

Our company in a few words

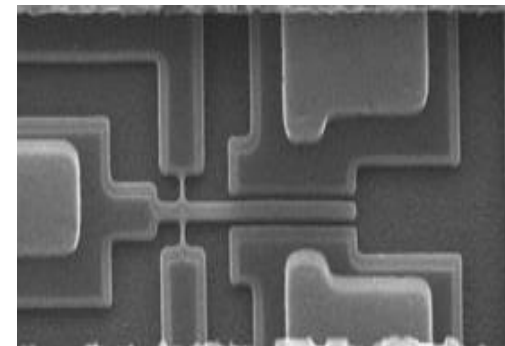


30 Collaborators :

- R&D, Sales, Admin **Grenoble : 18 people (4 PhDs, 8 Master degree)**
- Manufacturing in **Pau : 8 people**
- Subsidiary in **Beijing : 2 people**



Based on 8 years of Joint R&D with CEA (France) and CALTECH (USA)
20 patents that protect the technology



5 rounds of Investment for a total of 25 M€ raised



Industrial Partnerships with Leading Oil and Gas Players

Our history

- 2006-2011 : collaboration between CEA-LETI (Grenoble) and Pr. Roukes from Caltech (USA) on NEMS technology for gas sensing application.
- 2011 : Apex incorporated in December 2011
- 2013 : first demonstration of a miniaturized GC analyzer using a NGD detector
- 2014 : first generation of products is launched
- 2015 : first round of funding
- 2016 : Chrompix V1 is OIML R140 Certified to measure the calorific value
- 2017 : Apex acquires nCx to reinforce its production capacity. Second round of funding to expand our development
- 2018-2019 : development of the second generation of products
- 2019 : Customers located in Europe, China, North America. Turnover 1M€.
- 2020 : development of third generation of products to measure gas and liquid Turnover 1.8M€
- 2021 : selected by the EIC accelerator to develop new generation of instruments to address the green energy market (H₂, biogas, biomethane, CO₂,)
- 2024 : Turnover 3.5M€

➤ ADDITIONAL REFERENCE

› Bringing a hardware product to market: navigating the wild ride from concept to mass production, Elaine Chen (MIT)

› pierre.puget@m4x.org